

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Junji KOMENO, et al.

Appln. No.: 10/002,177

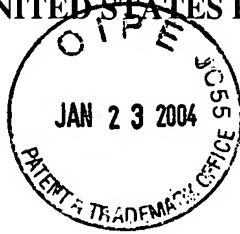
Confirmation No.: 2265

Filed: December 05, 2001

Docket No: Q67579

Group Art Unit: 1763

Examiner: Ram N. KACKAR



For: FILM-FORMING DEVICE WITH A SUBSTRATE ROTATING MECHANISM

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

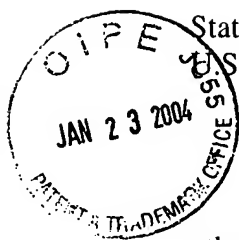
Sir:

Please review and enter the following remarks summarizing the interview conducted on December 17, 2003 between Examiner Ram Kackar and Kevin Barner:

REMARKS

An Examiner's Interview Summary Record (PTO-413) has not been received as of the filing of this statement.


During the interview the Examiner maintained his position that the prior art of record cited in the office action teaches the invention as presently claimed. However, the Examiner agreed that the prior art does not teach all aspects of the reacting chamber as set forth in the body of the specification of the application. The Examiner agreed to consider and enter or at least discuss the present claim amendments if they are deemed not to place the application in condition for immediate allowance.



Statement of Substance of Interview
U.S. Appln. No. 10/002,177

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,


Kevin M. Barner
Registration No. 46,075

SUGHRUE MION, PLLC
Telephone: (202) 293-7060
Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: January 23, 2004

Attorney Docket No.: Q67579